

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0

Title of Invention	METHOD OF FABRICATING POLY-CRYSTAL ITO FILM AND POLYCRYSTAL ITO ELECTRODE
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Application Number :

Confirmation Number:

First Named Applicant: Fang-An Shu

Attorney Docket Number: 14150-US-PA

Art Unit:

Examiner:

Search string: (6448158 or 6218310).pn

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	6448158	2002-09-10	Chih-Yu Peng	B2	438	487
	2	6218310	2001-04-17	Lewis Shen	B1	438	714

Signature

Examiner Name	Date